



## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re application of

Confirmation No: 6434

Suk Won CHOI, et al.

Group Art Unit: 2871

Application No.: 10/017,416

Examiner: Hoan C. NGUYEN

Filed: December 18, 2001

Customer No: 30827

For: MI

METHOD OF FABRICATING FERROELECTRIC LIQUID CRYSTAL

DISPLAY

## REQUEST FOR RECONSIDERATION

Mail Stop AF Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

## **INTRODUCTORY COMMENTS**

In response to the Examiner's Final Office Action dated November 18, 2003, the following remarks are respectfully submitted.

Remarks/Arguments begin on page 2 of this paper.

AMENDMENT TRANSMITTAL LETTER Application No. Filing Date 10/017,416 \ December 18, 2001 Applicant(s): Suk-Won Choi et al.

Examiner H. C. Nguyen Art Unit 2871

Docket No.

8733.535.00-US

Invention: METHOD OF FABRICATING FERROELECTRIC LIQUID CRYSTAL DISPLAY

## TO THE COMMISSIONER FOR PATENTS

Transmitted herewith is an amendment in the above-identified application.

The fee has been calculated and is transmitted as shown below.

		CLAIM	S AS AMENI	DED	
	Claims Remaining After Amendment	Highest Number Previously Paid	Number Extra Claims Present	Rate	
Total Claims	27	- 27 =		×	0.00
Independent Claims	4	- 4 =		x	0.00
Multiple Depend	dent Claims (ch	eck if applicabl	e)		
Other fee (pleas	se specify):				
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT:					0.00
x Large Entity Small Entity					
X No additiona	al fee is require	d for this amer	ndment.		
	ge Deposit Acc			n the amount of	\$·
A check in the	he amount of \$		to cover	the filing fee is	enclosed.
	credit card. Fo			_	
	r is hereby auth d below. A dup		~	Deposit Accourenclosed.	nt No50-0911
x Credit a	ny overpaymer	ıt.			
x Charge	any additional fili	ng or applicatio	n processing t	fees required und	der 37 CFR 1.16 and 1.17
Valeur Kurt M. Eaton Attorney Reg. N	•	Reg No. 5	3,005	Dated: _	February 18, 2004
MCKENNA LO 1900 K Street,	NG & ALDRIDO N.W.	GE LLP			

Washington, DC 20006

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